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**LOS ANGELES+ 6-10 AUG**

THE PREMIER CONFERENCE & EXHIBITION ON  
COMPUTER GRAPHICS & INTERACTIVE TECHNIQUES

# Scratch-based Reflection Art via Differentiable Rendering

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## 3D REFLECTION ARTS



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[Sakurai et al. 2018]



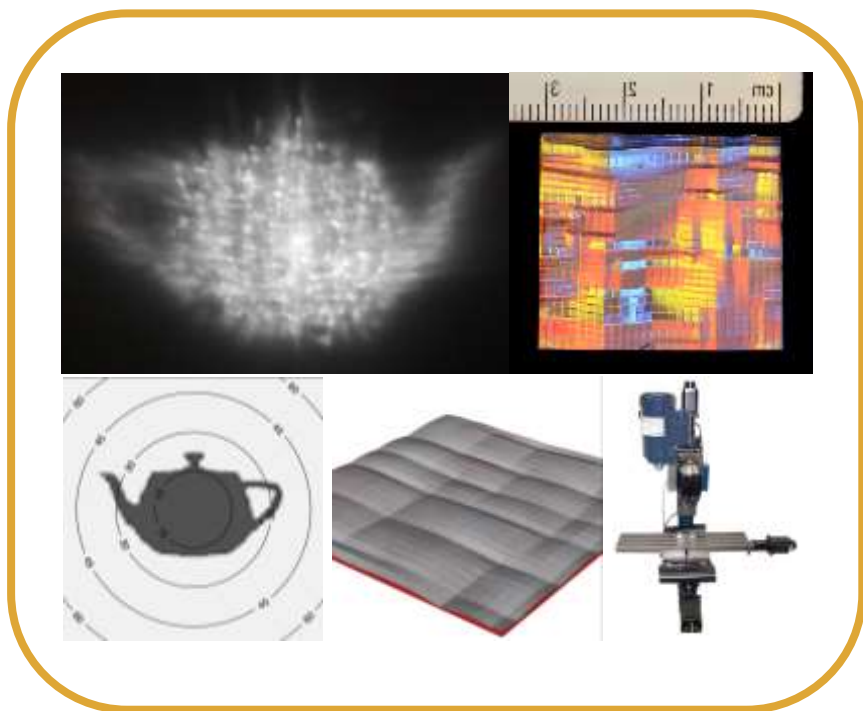


## PREVIOUS WORK

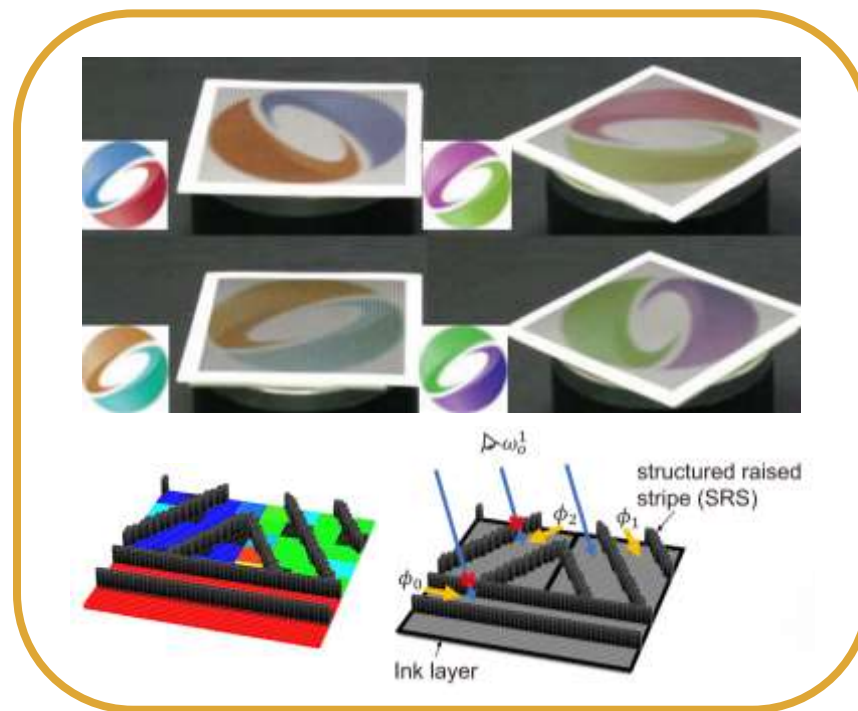


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- Low resolution (30x30 facets)
- Single pattern
- Computation time (a few hours)



[Weyrich et al. 2009]



[Sakurai et al. 2018]



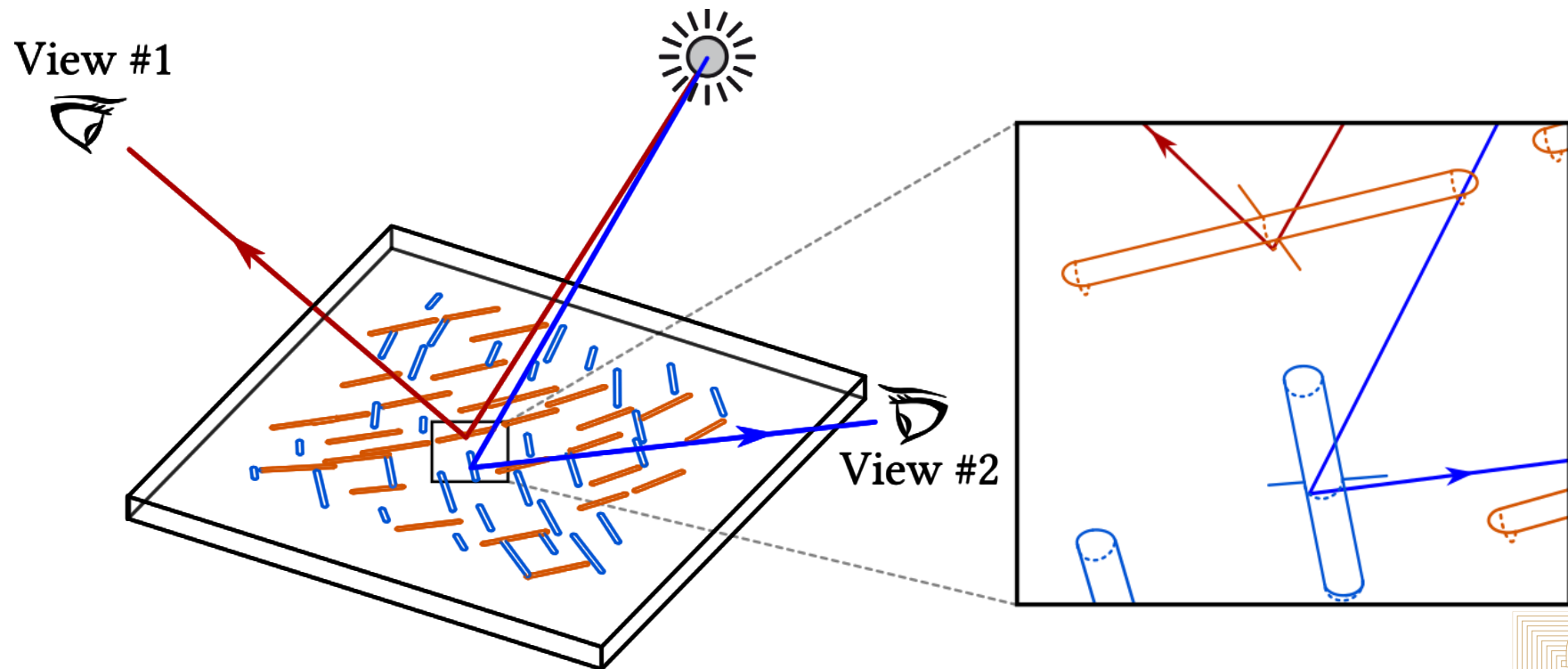
Scratches:

- Easy to fabricate
- No limitation from resolution



# → SCRATCH-BASED REFLECTION ART

- Special optical properties







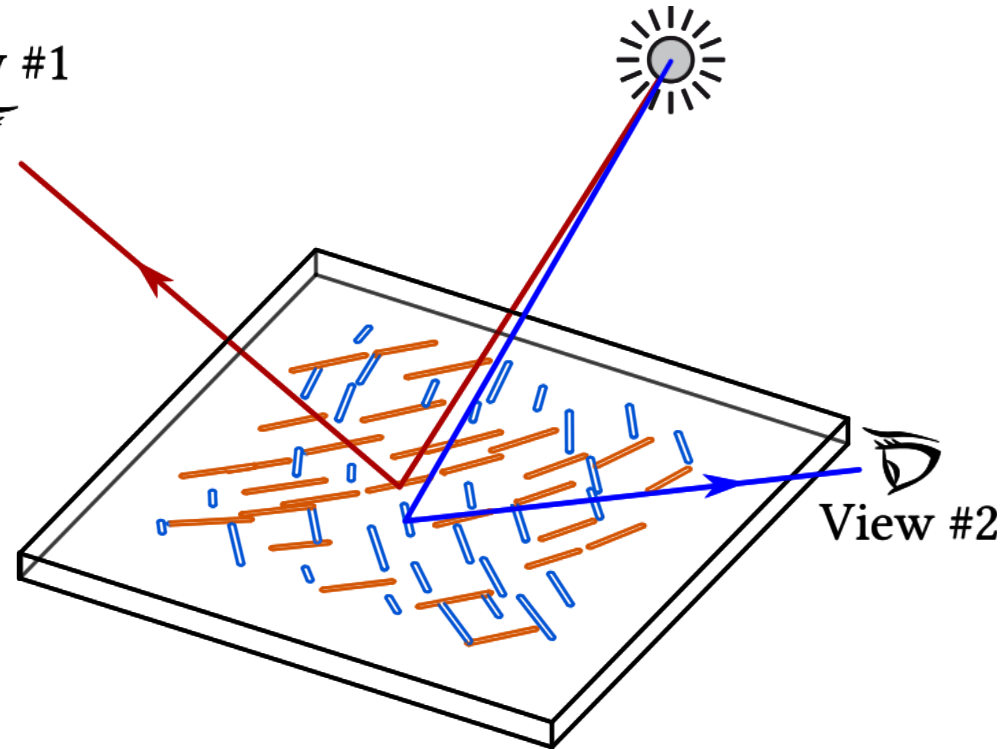
# PROBLEM STATEMENT



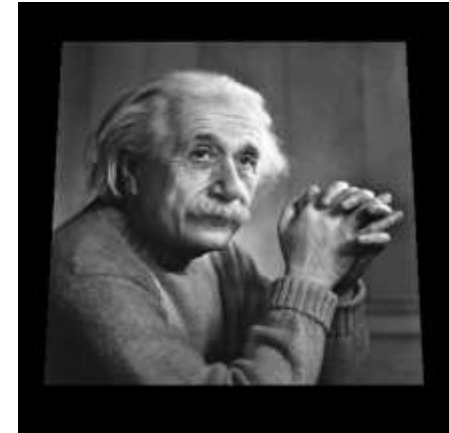
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View #1



View #2





# FORMULATION



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Scratches' parameters

View Light

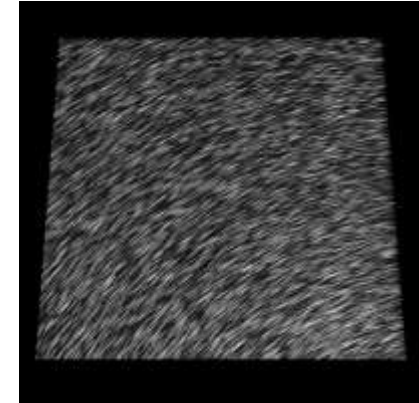
$$\min_{\mathcal{S}} E_{\text{loss}} (\{I_j(\mathcal{S}; V_j, L_j), T_j\}_j)$$

Rendered result

Target

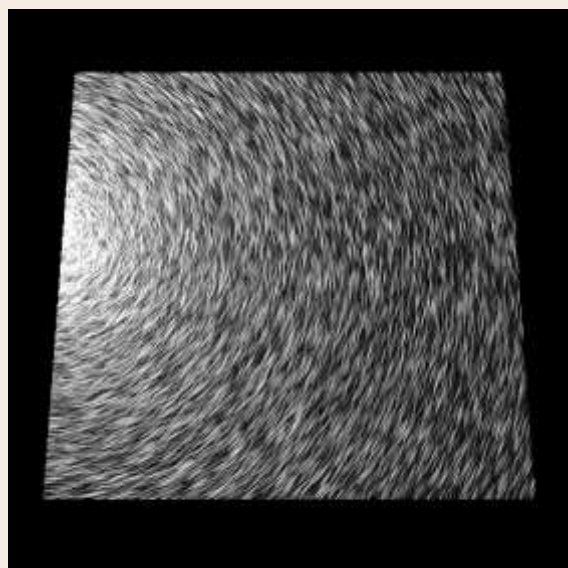
Main challenges:

Efficient rendering and optimization of scratches

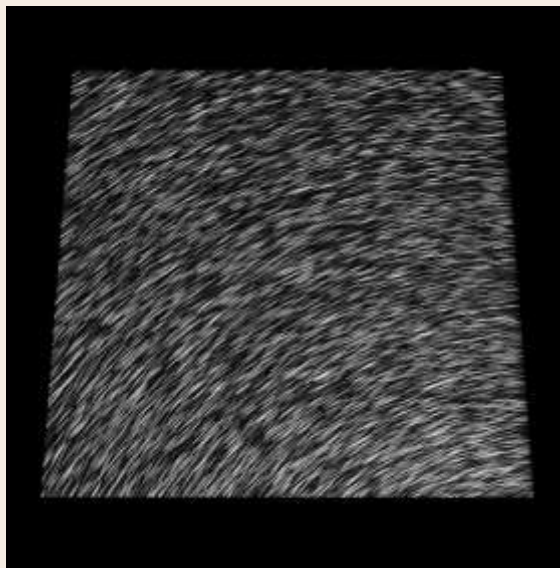


## → OUR SOLUTION

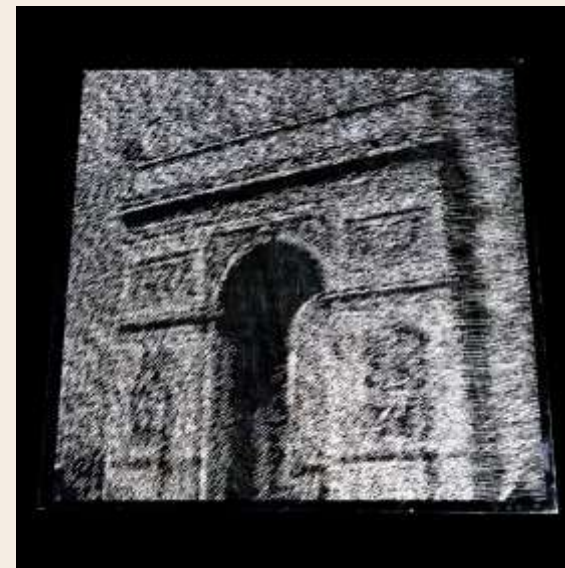
Analytical scratch models



Inverse rendering pipeline



Real objects fabrication



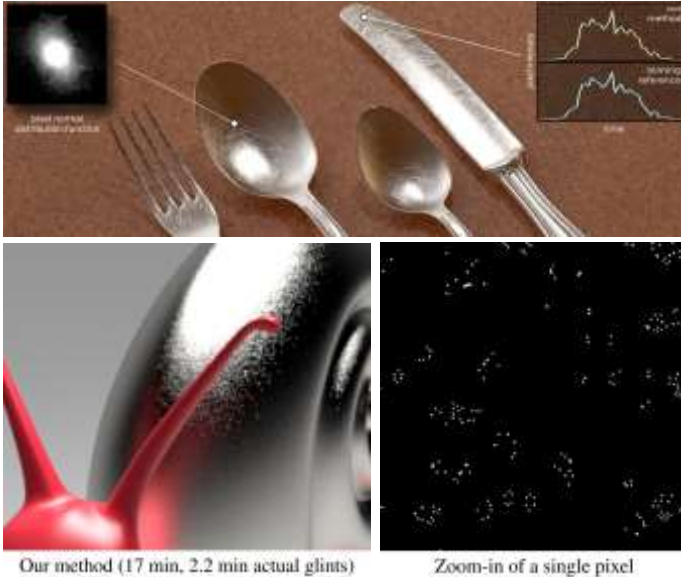




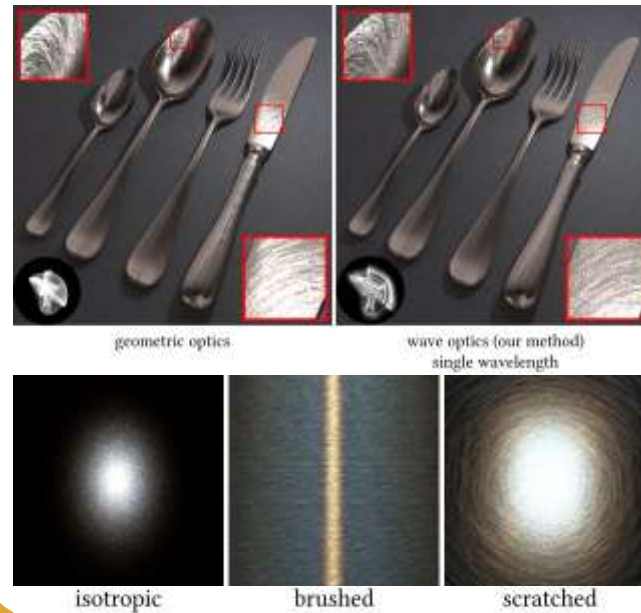
# GLINTS RENDERING



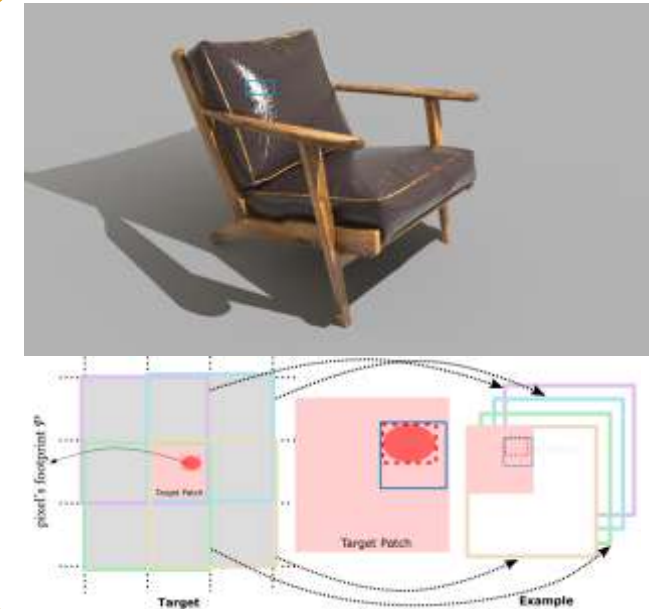
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[Yan et al. 2014]



[Yan et al. 2018]



[Wang et al. 2020]

- High-resolution normal maps are challenging for optimization

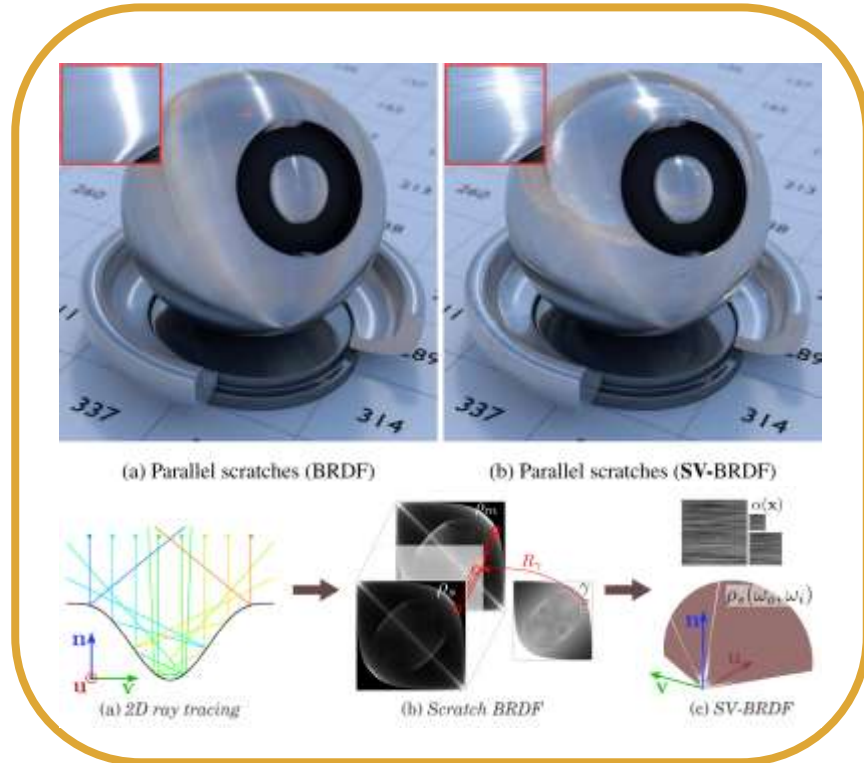




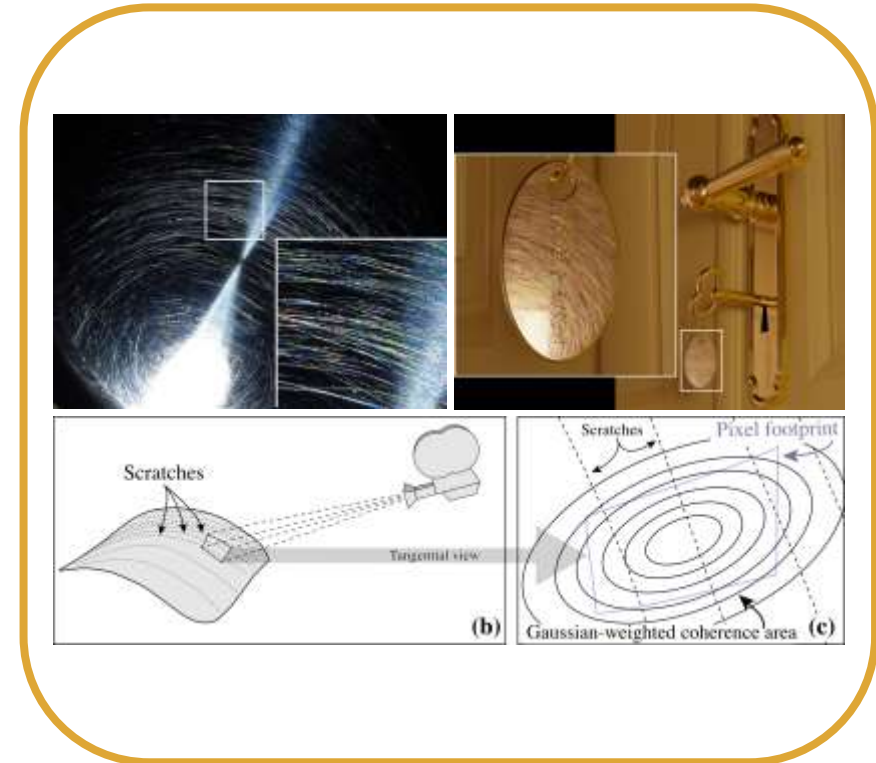
## PREVIOUS WORK



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[Raymond et al. 2016]



[Werner et al. 2017]



## → DESIRED FEATURE OF THE SCRATCH MODEL

- Individual scratch representation
- Efficient for forward rendering
- Easy to perform differentiable rendering

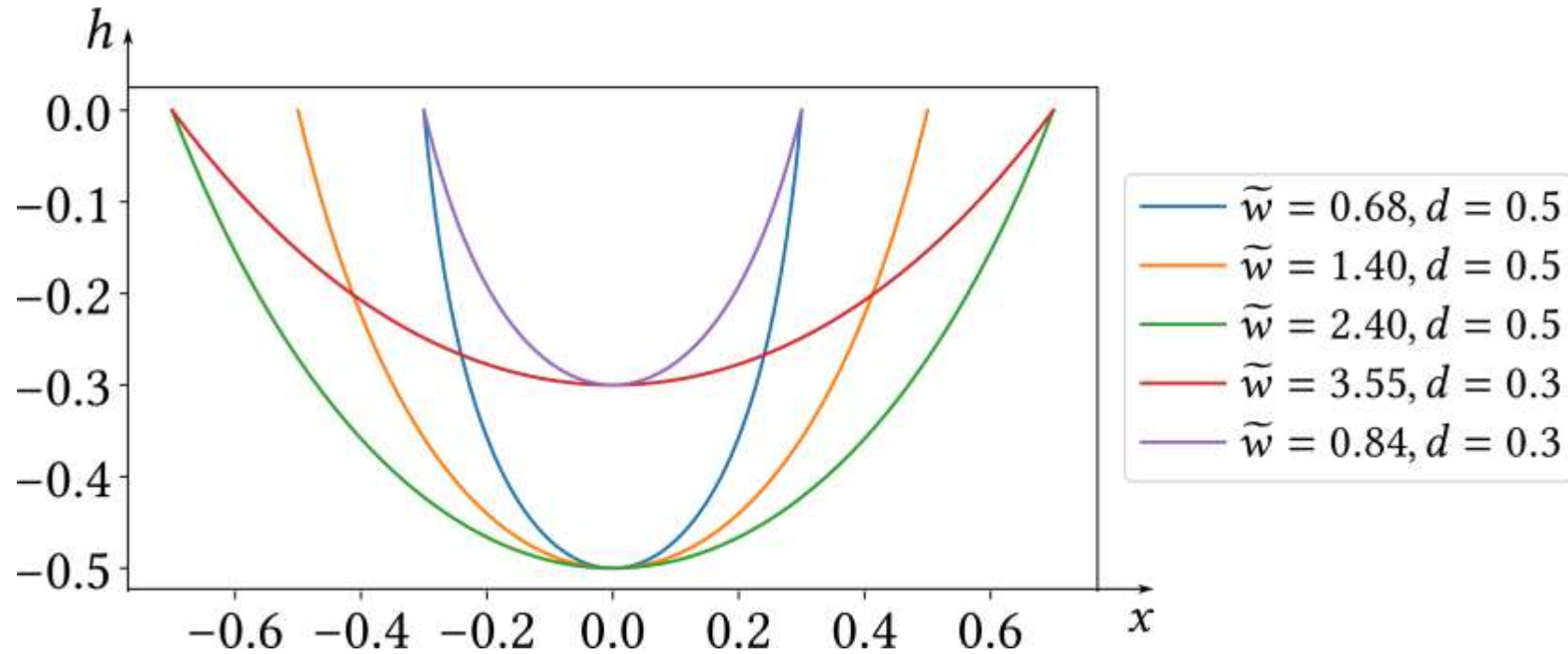




# SCRATCH GEOMETRIC MODEL



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$$h(x; \tilde{w}, d) = -\frac{1}{2} \tilde{w} \log \left( 1 - \frac{4x^2}{\tilde{w}^2} \right) - d$$





# SCRATCH SHADING MODEL

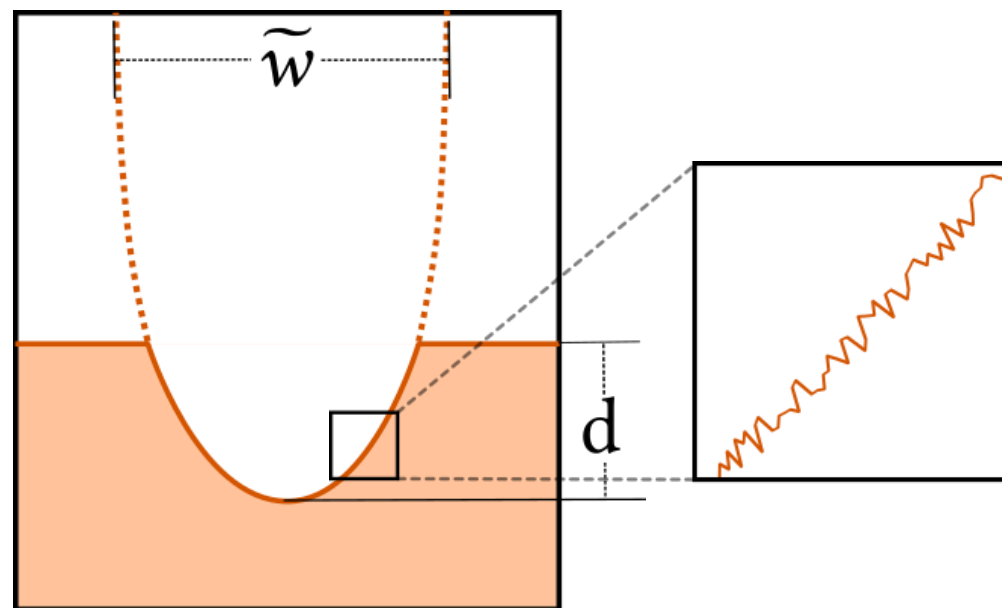


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$$\begin{aligned}\mathbf{n}(x; \tilde{w}) &= \frac{(-h_x(x; \tilde{w}, d), 0, 1)}{\|(-h_x(x; \tilde{w}, d), 0, 1)\|} \\ &= \left( -\frac{4\tilde{w}x}{\tilde{w}^2 + 4x^2}, 0, \frac{\tilde{w}^2 - 4x^2}{\tilde{w}^2 + 4x^2} \right)\end{aligned}$$

Point NDF

$$D_x(\mathbf{h}, \mathbf{n}(x)) = \frac{\alpha^2 \chi^+(\mathbf{n}(x) \cdot \mathbf{h})}{\pi ((\mathbf{n}(x) \cdot \mathbf{h})^2 (\alpha^2 - 1) + 1)^2}$$







# SCRATCH SHADING MODEL



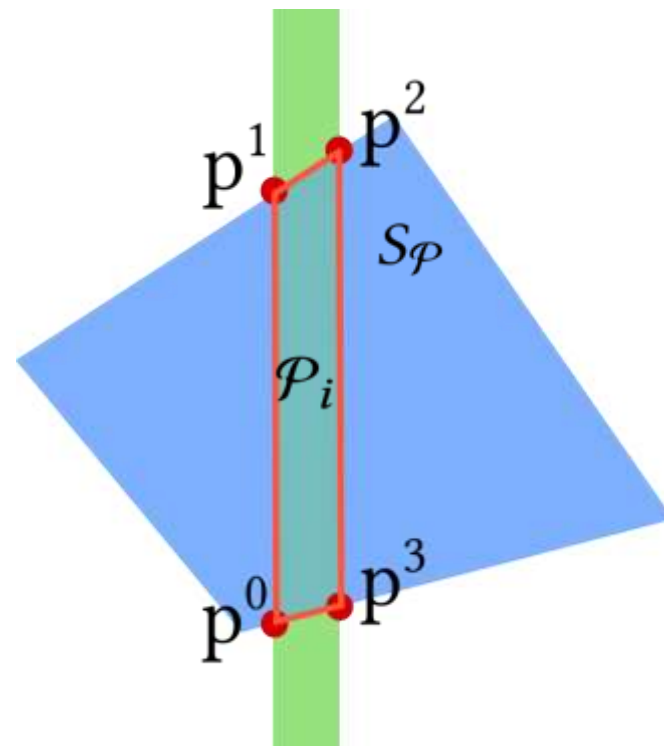
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Patch NDF (Single scratch)

$$D_i(\mathbf{h}) = \frac{1}{S_{\mathcal{P}}} \int_{\mathcal{P}_i} D_x(\mathbf{h}, \mathbf{n}(x)) \, dx dy$$



$$\hat{D}_i(\mathbf{h}) = \sum_{k=1}^{K} \int_{p_x^k}^{p_x^{k+1}} S(x) D_x(\mathbf{h}, \mathbf{n}(x)) dx$$





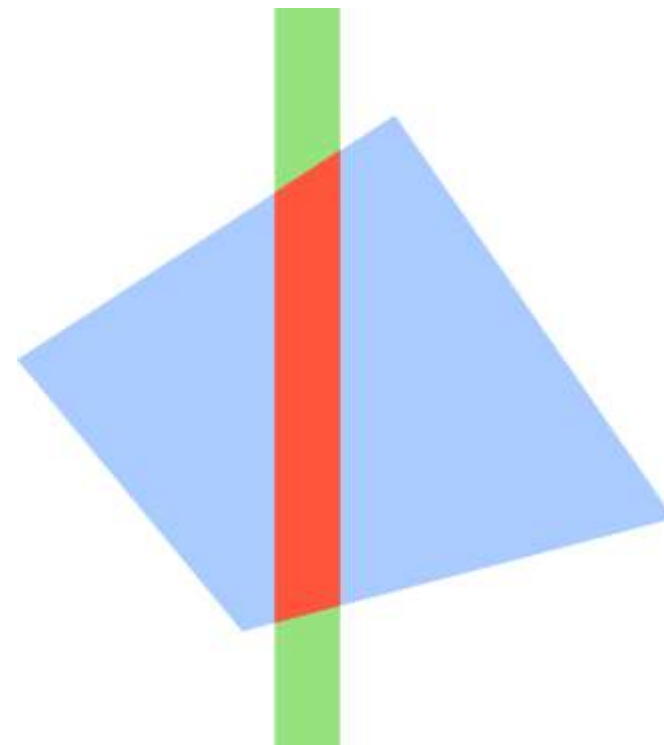
# SCRATCH SHADING MODEL



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$$D_{\mathcal{P}}(\mathbf{h}) = \sum_{i \in \mathcal{P}} D_i(\mathbf{h})$$

$$f_{\text{scratch}}(\omega_i, \omega_o) = \frac{D_{\mathcal{P}}(\mathbf{h}) G(\omega_i, \omega_o) F(\omega_o, \mathbf{h})}{4 |\omega_i \cdot \mathbf{n}| |\omega_o \cdot \mathbf{n}|}$$

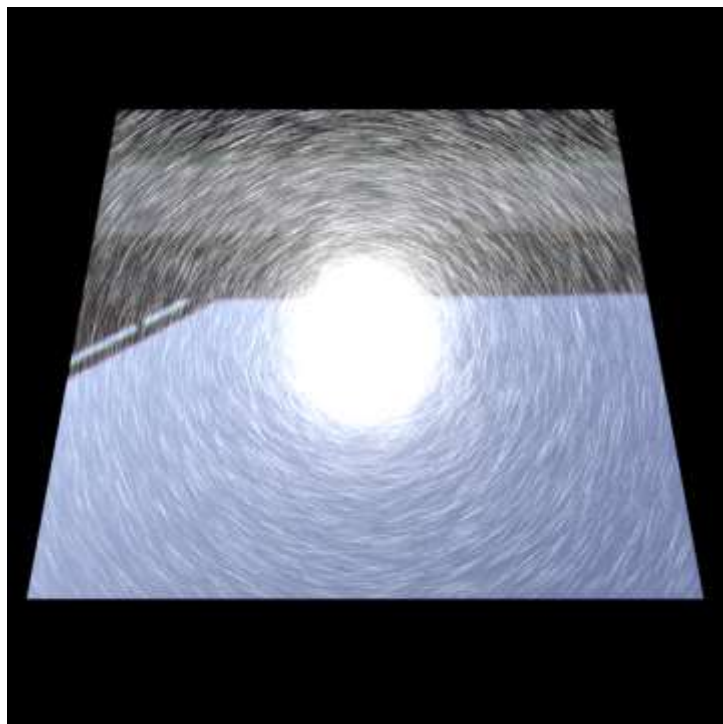




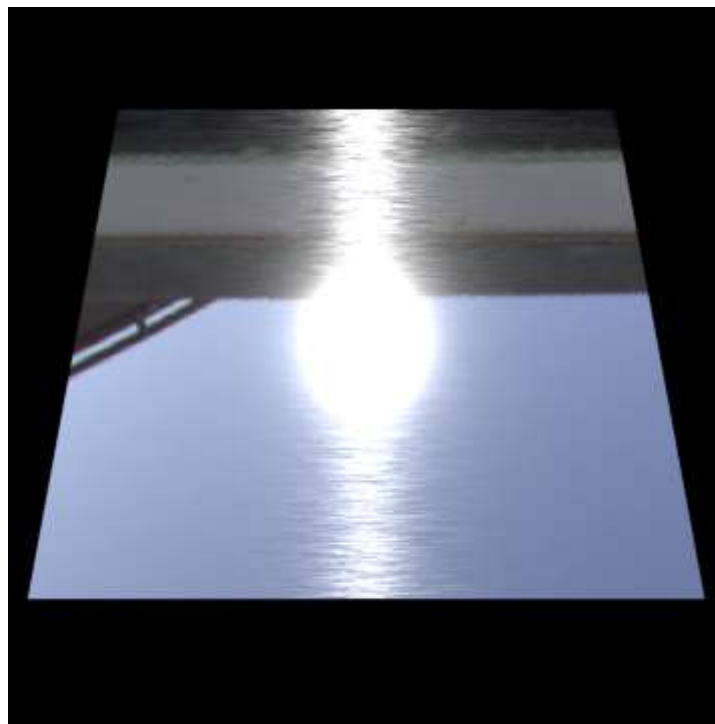
# SCRATCH SHADING MODEL



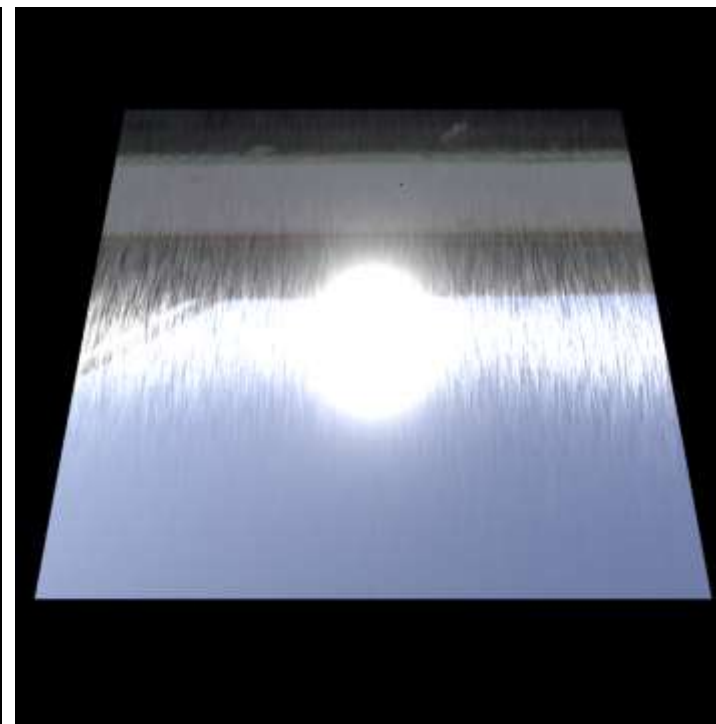
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Random



Horizontally-brushed

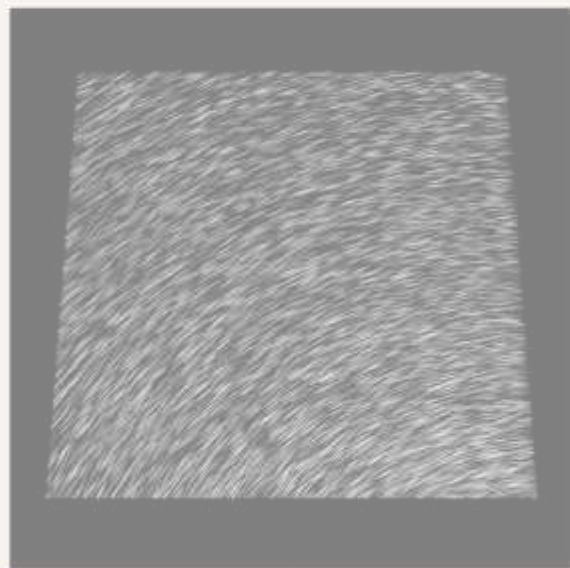


Vertically-brushed

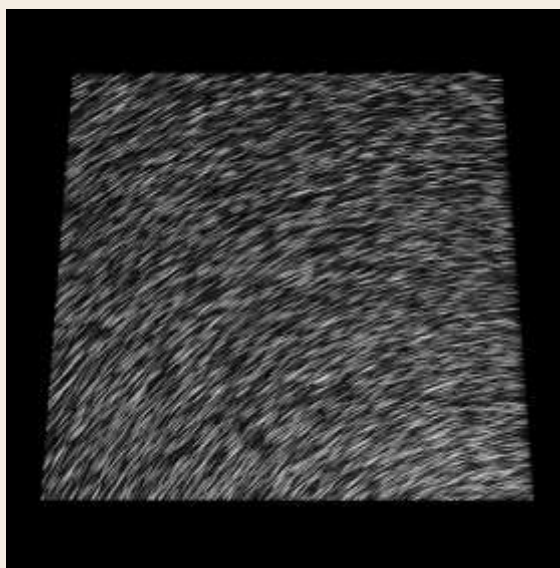


## → OUR SOLUTION

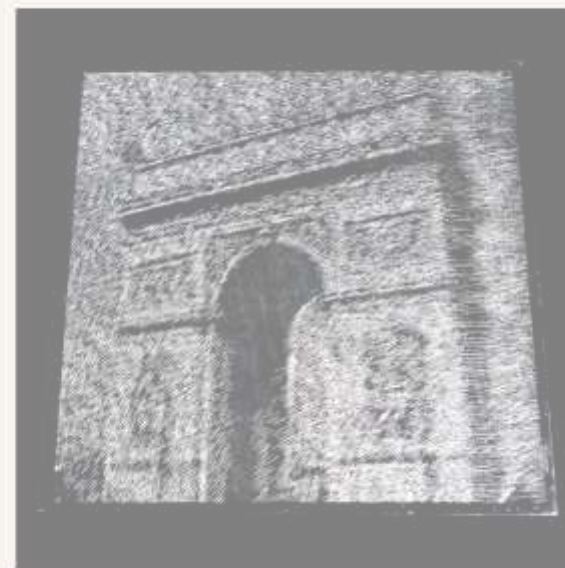
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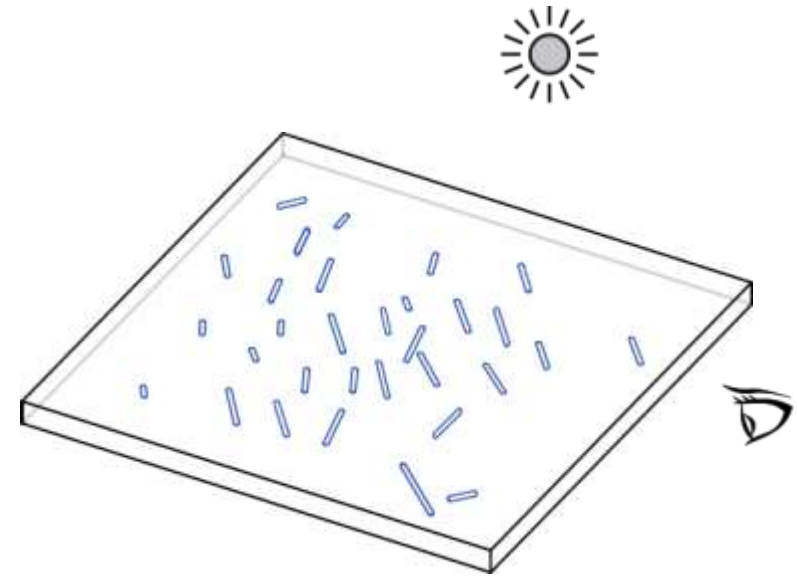


## → INVERSE PARAMETER ESTIMATION

$$\min_{\mathcal{S}} E_{\text{loss}} \left( \{I_j(\mathcal{S}; V_j, L_j), T_j\}_j \right)$$

Scratch parameters

Fixed







## LOSS FUNCTION



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$$E_{\text{loss}} = \lambda_p E_p + \lambda_g E_g$$

- Perceptual loss (Chizhov et al. [2022])

$$E_p = \sum_j ||g * (I_j - T_j)||_2^2$$

- Gram matrix loss (Gatys et al. [2015])

$$E_g = \sum_j ||\text{Gram}(I_j) - \text{Gram}(T_j)||_2^2$$

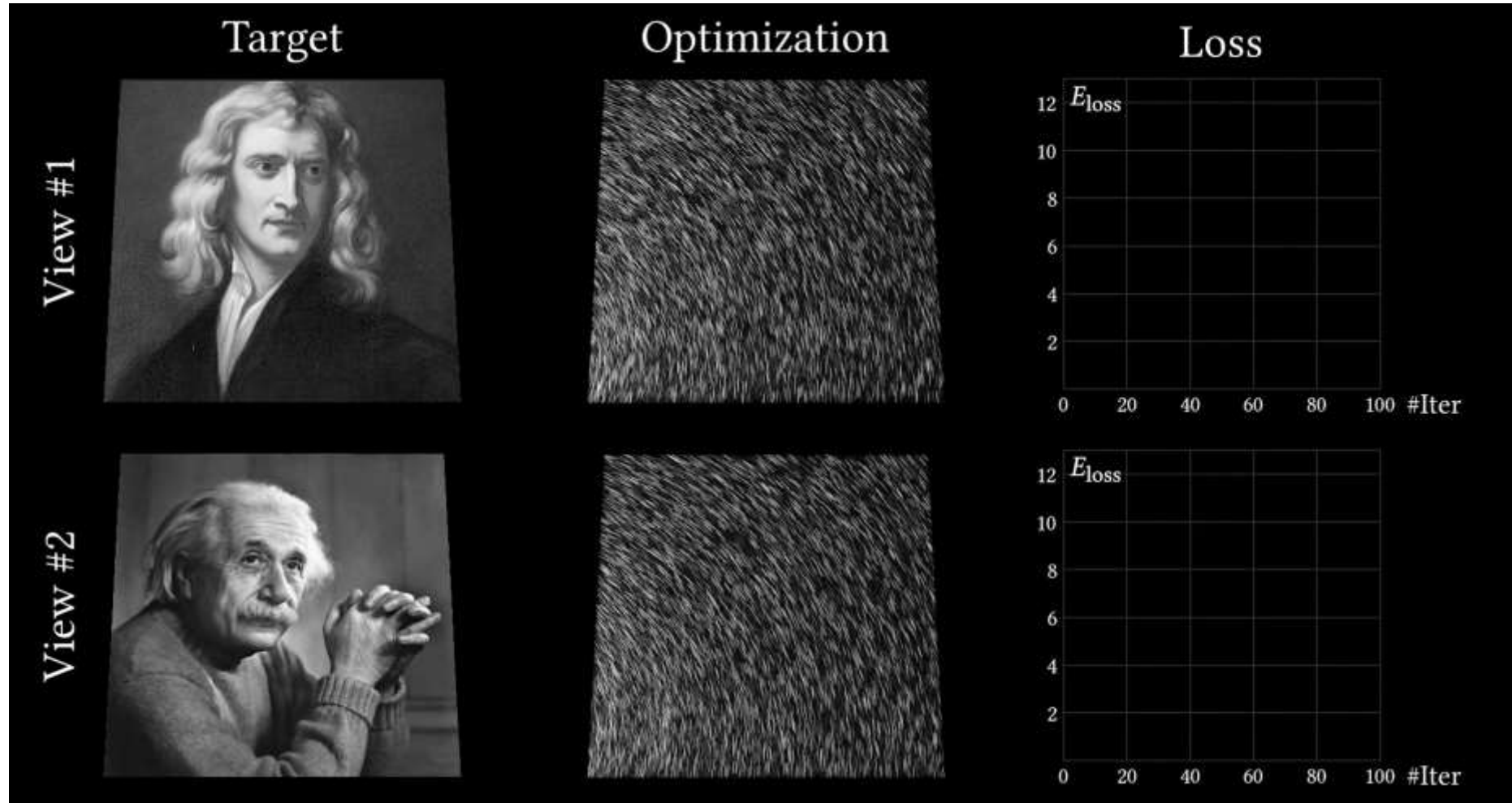




# OPTIMIZATION



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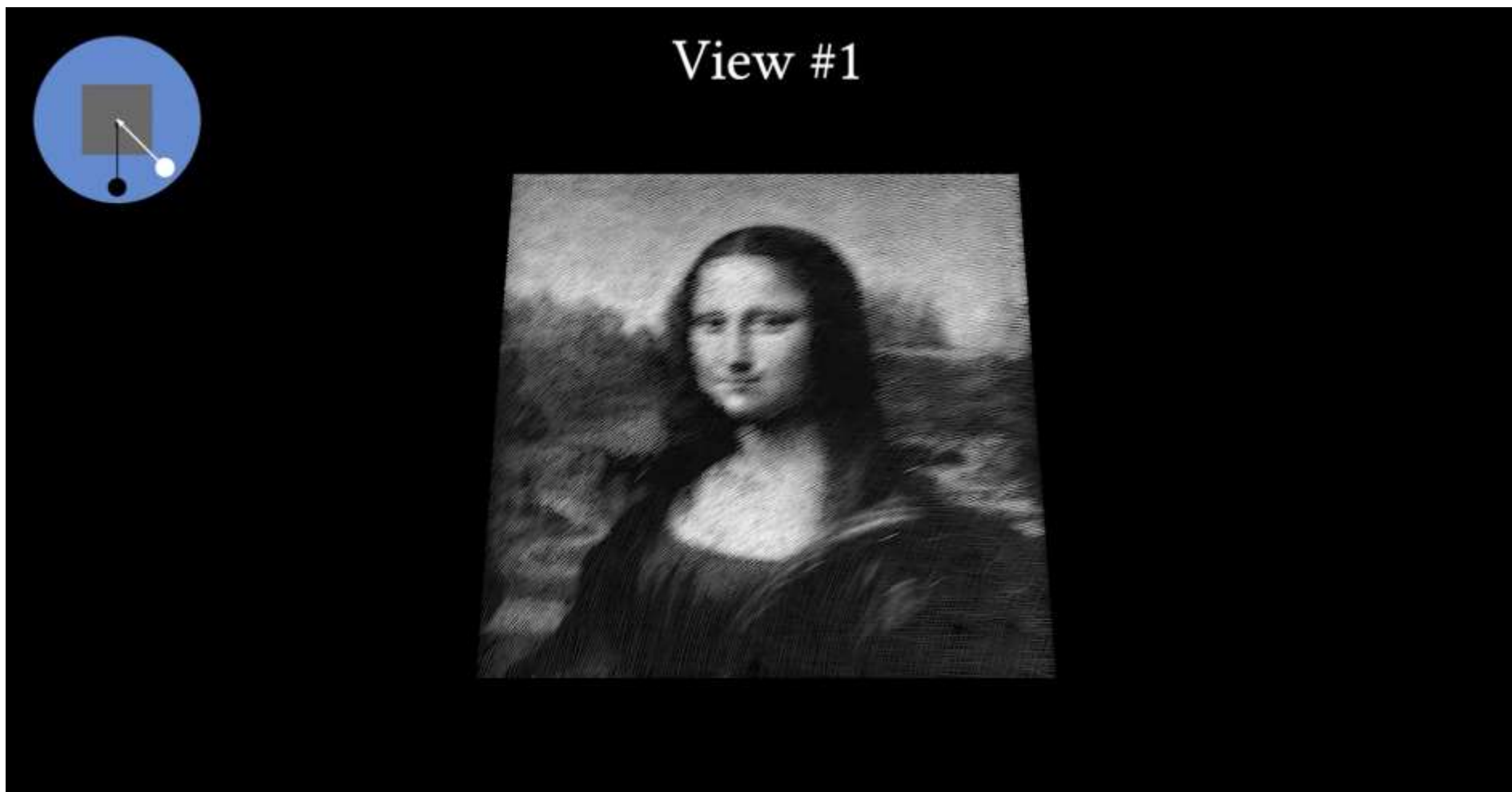




# VIRTUAL RESULTS

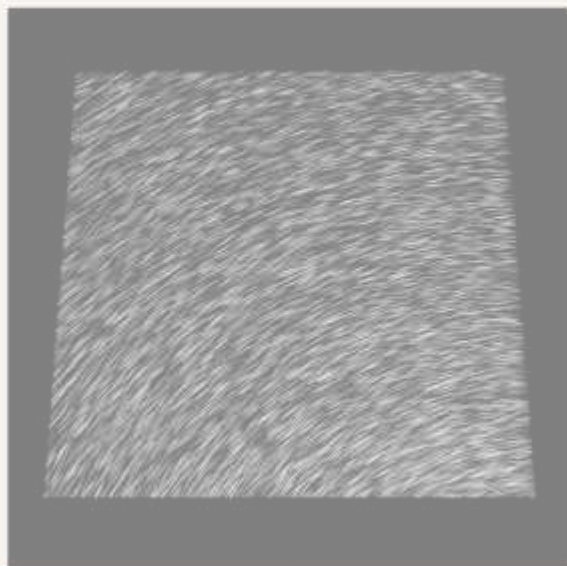


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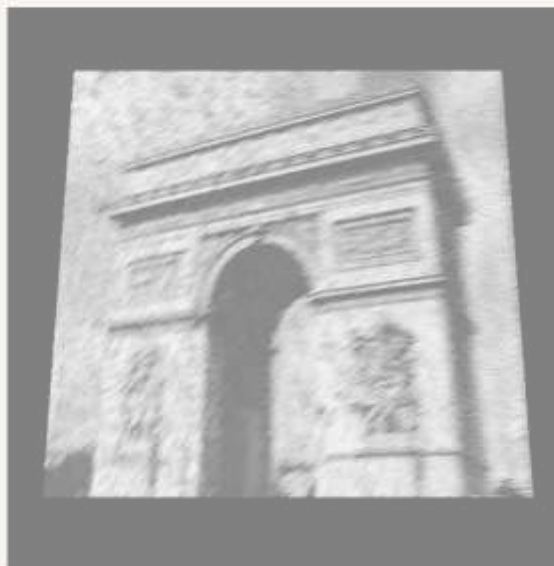


## → OUR SOLUTION

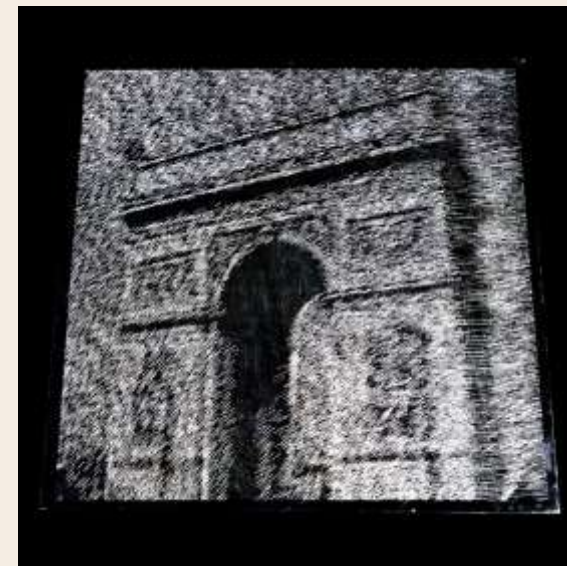
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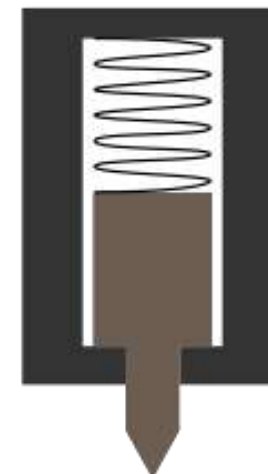




# MANUFACTURE SETUP



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# MANUFACTURE



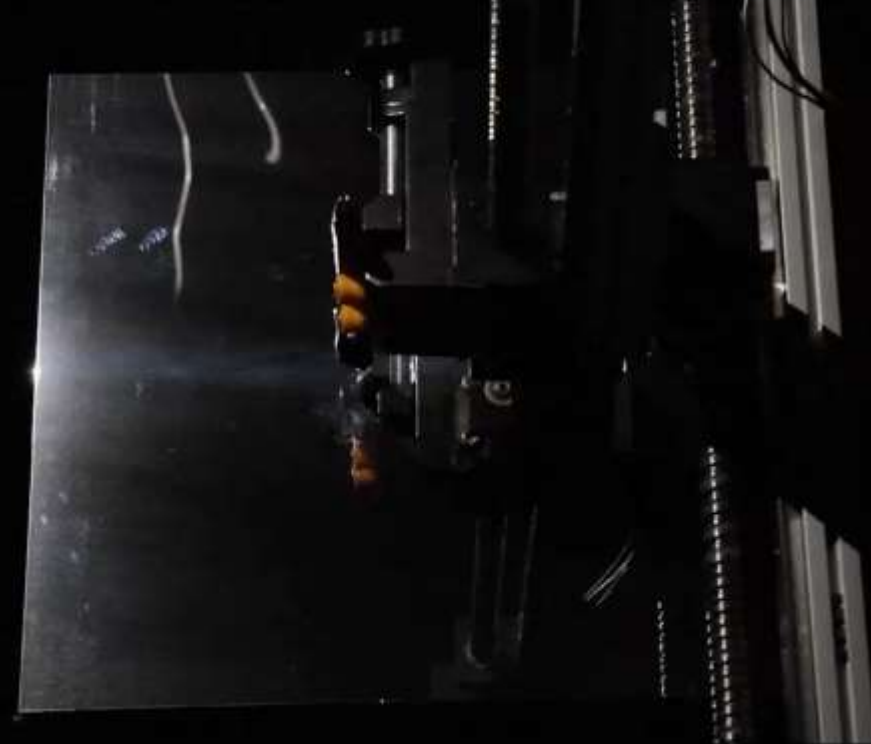
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Video from two different views for the same manufacturing process

Camera #1



Camera #2





# MANUFACTURED RESULTS



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View #1





## CONCLUSION



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- Present scratch-based reflection art
- Introduce differentiable rendering for scratches
- Fabricate designed reflectors with a simple carving machine



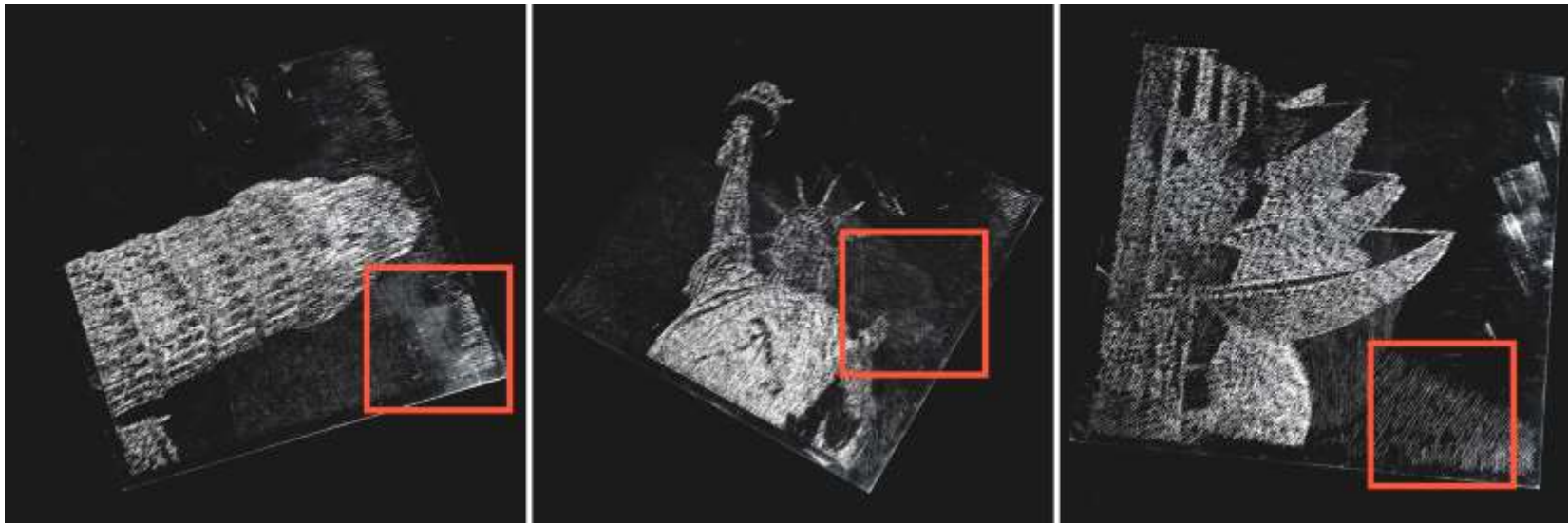


## LIMITATIONS



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- Expressiveness of our geometric and shading models
- Conflicts among different views



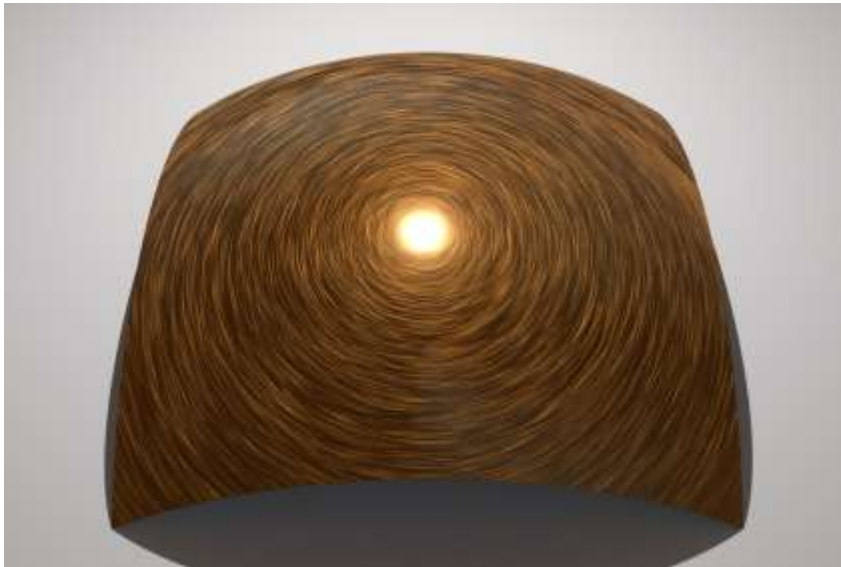


## FUTURE WORK



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- Design scratched-based reflection art on non-planar objects
- More applications like hair reconstruction



[Kuang et al. 2022]







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# THANK YOU!

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<https://wangningbei.github.io/>

<http://staff.ustc.edu.cn/~lgliu/>

